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# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

JOZEF D. MITROS ET AL.

Serial No. 10/020,034 (TI-32931)

Filed December 7, 2001

For: METHOD FOR FABRICATING LOW CHC DEGRADATION MOSFET TRANSITSORS

Art Unit 2823

**Examiner Long Pham** 

Customer No. 23494

Director of the United States Patent and Trademark Office P. O. Box 1450 Alexandria, VA 22313-1450

### CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

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Jay M. Cantor, Reg. No. 19.906

## **BRIEF ON APPEAL**

### **REAL PARTY IN INTEREST**

The real party in interest is Texas Instruments Incorporated, a Delaware corporation with offices at 7839 Churchill Way, Dallas, Texas 75251.

### RELATED APPEALS AND INTERFERENCES

There are no known related appeals and/or interferences.

### **STATUS OF CLAIMS**

This is an appeal of claims 18, 19, 26 and 27, all of the rejected claims. Claims 1 to 17, 20 to 25 and 28 to 30 have been allowed. Please charge any costs to Deposit Account No. 20-0668.

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